



Image Rce/1763/
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

March 8, 2004

In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner: R. Zervigon

Filed: September 27, 2000

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

**PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)
AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Continued Examination for the above-identified patent application. The shortened statutory period for response having expired on January 7, 2003, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 151845 in the amount of \$ 310.00 pursuant to 37 CFR §1.17. (Payment of \$110.00 for a one month extension was already made.)

The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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